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U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NUM FILING DATE CLASS SUBCLASS GAU EXAMINER
10034366 01/03/2002 430 322 1756 *David A. Chou & David*

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**CONTINUING DATA VERIFIED:

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** FOREIGN APPLICATIONS VERIFIED:
JAPAN 2001-112174 11/04/2001

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☐ yes ☐ no
35 USC 119 conditions met ☐ yes ☐ no
Verified and Acknowledged Examiners's initials

ATTORNEY DOCKET NO
740189-717

TITLE : Pattern formation material and pattern formation method

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED		
			Total Claims	Print Claim for O.G.	
ISSUE FEE		Primary Examiner	DRAWING		
Amount Due	Date Paid		Sheets Drwg.	Figs.Drwg.	Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner		
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